

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Naofumi NAKAMURA et al.
Serial No. : 10/752,642
For : SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME
Filed : January 7, 2004
Examiner : Chris C. Chu
Art Unit : 2815
Confirmation No. : 4109

Do Not Enter
C.C.
9/21/08

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RESPONSE TO FINAL OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action dated June 6, 2008, please consider the following remarks.

Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.